

| L Number | Hits | Search Text | DB | Time stamp |
|----------|-------|---|---|---------------------|
| 1 | 27375 | semiconductor and (tft or (thin adj film adj transistor)) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/03/02 09:51 |
| 2 | 343 | (semiconductor and (tft or (thin adj film adj transistor))) and (alno or alon or ((aluminum adj nitride) and oxygen)) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/03/02 09:53 |
| 3 | 343 | ((semiconductor and (tft or (thin adj film adj transistor))) and (alno or alon or ((aluminum adj nitride) and oxygen))) and substrate | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/03/02 10:41 |
| 4 | 237 | (semiconductor and (tft or (thin adj film adj transistor))) and (alnc or alcn or ((aluminum adj nitride) and carbon)) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2004/03/02 10:42 |